

LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT

Applicant
 Noorbakhsh, et al.

Confirmation
 No.:

(Use several sheets if necessary)

Filing Date

Group

Examiner Not yet assigned

Herewith

Not yet assigned

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
<i>Lei</i>	A1	5,824,158	10-98	Takeuchi, et al.	118	723IR	<i>10/05/03 10 U.S. PTO</i>
	A2	5,968,276	10-99	Lei, et al.	118	723R	<i>10/05/03 10 U.S. PTO</i>
	A3	6,143,078	11-00	Ishikawa, et al.	118	715	<i>10/05/03 10 U.S. PTO</i>
	A4	6,176,198 B1	01-01	Kao, et al.	118	723ME	<i>10/05/03 10 U.S. PTO</i>
	A5	6,273,022 B1	08-01	Pu, et al.	118	723I	<i>10/05/03 10 U.S. PTO</i>
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						

Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1						<input type="checkbox"/>	<input type="checkbox"/>
	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>
	B4						<input type="checkbox"/>	<input type="checkbox"/>
	B5						<input type="checkbox"/>	<input checked="" type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
<i>Lei</i>	C1	U.S. Patent Application No. 09/461,682 filed December 14, 1999 Entitled "Plasma Reactor Cooled Ceiling with an Array of Thermally Isolated Plasma Heated Mini-Gas Distribution Plates"
	C2	
	C3	

Examiner *Lei*

Date Considered *4/15/03*

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.